

Docket Number: 071469-0305918

Client Reference: RAJ-014

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re the Application of

NORIAKI FUKIAGE, et al.

Application No.: 10/702,049

Filed: November 6, 2003

Group Art Unit: 1763

Examiner:

Confirmation No.: 7419

For: METHOD OF IMPROVING POST-DEVELOP PHOTORESIST PROFILE ON A
DEPOSITED DIELECTRIC FILM

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR 1.56, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached PTO-1449. As this application was filed after June 30, 2003, no copies of the cited U.S. patents/patent application are enclosed. However, one copy of each non-patent reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom. Applicants respectfully request the Examiner return an initialed copy of the enclosed Form PTO-1449 to Applicants with the next Office communication to indicate that the references have been considered, per MPEP § 609.

This Information Disclosure Statement is being filed before the mailing date of the first Office Action on the merits in the present application. No certification or fee is required.

These references were cited in an International Search Report, dated July 13, 2005, in the corresponding PCT/US2004/34102 application.

Respectfully Submitted,



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PTO/SB/08b (08-03)
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U.S. Patent and Trademark Office; U.S. DEPARTMENT OF COMMERCE

Substitute for form 1449B/PTO INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use as many sheets as necessary)		Complete if Known			
		Application Number	10/702,049		
		Filing Date	11/06/2003		
		First Named Inventor	NORIAKI FUKIAGE		
		Art Unit	1763		
		Examiner Name			
Sheet	1	of	1	Attorney Docket Number	071469-0305918

NON PATENT LITERATURE DOCUMENTS			
Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
	I	C.H.LIN ET AL., "A study on adhesion and footing issues of HMDSO films as bottom antireflective coating for deep UV lithographies," Microelectronic Engineering, Elsevier (Netherlands), Vol. 57- 58, pp. 555-561, (Sept., 2001).	
	II	SANG-YUN LEE ET AL., "Inorganic Si-O-C Antireflection Coating at 193 nm for Cu Dual Damascene Process," Journal of Electrochemical Society USA, Vol. 150 (No. 1), pp. G58-G61, (January, 2003).	

Examiner Signature		Date Considered	
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.
¹Applicant's unique citation designation number (optional). ²Applicant is to place a check mark here if English language Translation is attached.
This collection of information is required by 37 CFR 1.97 and 1.98. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to take 2 hours to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, U.S. Department of Commerce, P.O. Box 1450, Alexandria, VA 22313-1450. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

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